	Application No.	Applicant(s)	٠.
Notice of Allowability	09/825,518	FERNANDEZ ET AL.	
	Examiner	Art Unit	
	Kieu D Vu	2173	
The MAILING DATE of this communication app All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85 NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT F of the Office or upon petition by the applicant. See 37 CFR 1.31	S (OR REMAINS) CLOSED in the common of the c	n this application. If not included unication will be mailed in due course. TH	
1. This communication is responsive to <u>The Amendment file</u>	<u>d 09/07/04</u> .		
2. The allowed claim(s) is/are <u>8-11 (renumbered as 1-4)</u> .			
3. \boxtimes The drawings filed on $\underline{10/18/01}$ are accepted by the Exam	niner.		
 4. ☐ Acknowledgment is made of a claim for foreign priority to a) ☐ All b) ☐ Some* c) ☐ None of the: 1. ☐ Certified copies of the priority documents have 2. ☐ Certified copies of the priority documents have 3. ☐ Copies of the certified copies of the priority documents have 3. ☐ Copies of the certified copies of the priority documents have a copies of th	e been received. e been received in Application occuments have been received of this communication to file MENT of this application. Initted. Note the attached EX. res reason(s) why the oath of the submitted. Is on's Patent Drawing Review. It's Amendment / Comment of the header according to 37 Citosit of BIOLOGICAL MAT	on No d in this national stage application from the drawings in the front (not the back) of ERIAL must be submitted. Note the	-
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Attachment(s) 1. Notice of References Cited (PTO-892) 2. Notice of Draftperson's Patent Drawing Review (PTO-948) 3. Information Disclosure Statements (PTO-1449 or PTO/SB/Paper No./Mail Date 4. Examiner's Comment Regarding Requirement for Deposit	6. Interview S Paper No. 08), 7. Examiner's	formal Patent Application (PTO-152) ummary (PTO-413), /Mail Date Amendment/Comment Statement of Reasons for Allowance	
of Biological Material		JOHN CABECA PERVISORY PATENT EXAMINF TECHNOLOGY CENTER 210	_